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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Please Enter 4/11/2006
HAYAKAWA, Akinori, et al.

Group Art Unit: 2814

Serial No.: 10/690,469

Examiner: **Howard WESS**

Filed: **October 22, 2003**

P.T.O. Confirmation No.: 4849

**FOR: PHOTOSEMICONDUCTOR DEVICE, METHOD FOR FABRICATING
PHOTOSEMICONDUCTOR DEVICE AND METHOD FOR DRIVING
PHOTOSEMICONDUCTOR DEVICE**

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. 1.312

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 19, 2006

Sir:

Applicants received a Notice of Allowance dated **November 4, 2005** in connection with the above-identified application. It is respectfully requested that the following amendments be made to the specification and claims of this application: